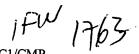
Attorney's Docket No.: 05542-459003 / 5353C1/CMF





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Wallace T.Y. Tang

Art Unit : 1763

Serial No.: 09/134,147

Examiner: Sylvia R. MacArthur

Filed

: August 14, 1998

Title

: IN-SITU REAL-TIME MONITORING TECHNIQUE AND APPARATUS FOR

DETECTION OF THIN FILMS DURING CHEMICAL/MECHANICAL

POLISHING PLANARIZATION

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF FEBRUARY 20, 2004

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Deposit

Signature

Typed or Printed Name of Person Signing Certificate